REMARKS

Claims 1-21, as amended, remain herein.

Claims 1 and 10-19 have been amended more clearly to recite applicants' invention. See applicants' specification, at page 7, last line to page 8, first line, and also page 13, lines 24-25. Both the electrodes and the terminals comprise at least one layer of conductor material that is the same as, and connected to, the helical conductor strip material. Minor, editorial changes have been made in claims 12-17.

1. Claims 1-21 were rejected under 35 U.S.C. § 103(a) over Toi et al. U.S. Patent 6,027,008 and Senda et al. U.S. Patent 5,197,170.

The presently claimed composite component comprises in a first embodiment, a helical conductor strip comprising at least a helical conductor material, a plurality of terminals each comprising at least one layer comprising the helical conductor material and located on an external peripheral surface of the composite component, wherein the electrode layers and the helical conductor strip are electrically connected to the

plurality of terminals, and the helical conductor strip and the at least one layer of each terminal are electrically connected.

In a second embodiment, the composite component comprises a helical conductor strip made of at least a helical conductor material and located on a peripheral surface of a component body, wherein the electrode layers comprise at least the helical conductor material and the helical conductor strip are electrically connected.

In summary, the presently claimed composite component comprises at least two electrodes and/or a plurality of terminals each comprising at least one layer of conductor material that is the same as, and connected to, the helical conductor strip material. This arrangement and corresponding method are nowhere disclosed or suggested in any of the cited references.

The Office Action alleges that Toi '008 discloses a helical coil conductor connected to terminal electrode layers.

Actually, Toi '008 discloses an electronic device having a helical coil wire conductor made of copper that is solid-phase welded to a solder barrier layer made of nickel formed on a

high-conductivity layer made of Ag, Ag-Pd, or a similar material, comprising the electrode terminals. The wire conductor is copper and is connected to an entirely different material, i.e., nickel, which in turn is located on a AG, Ag-Pd layer. The wire conductor and the electrode terminals comprise different materials and do not comprise a material layer in common to each other. Thus, Toi '008 does not disclose at least two electrodes and a plurality of terminals each comprising at least one layer of conductor material that is the same as, and connected to, the helical conductor strip material, as recited variously in applicants' claims 1, 10, 11, 18 and 19.

The Office Action admits that Toi '008 does <u>not</u> disclose a capacitor element formed of insulation and electrode layers, and cites Senda '170 as allegedly disclosing same. However, Senda '170 does <u>not</u> provide the deficiencies of Toi '008 described herein.

For the foregoing reasons, neither Toi '008 nor Senda '170 contains any teaching, suggestion, reason, motivation or incentive that would have led one of ordinary skill in the art to applicants' claimed invention. Nor is there any disclosure

or teaching in either of these references that would have suggested the desirability of combining any portions thereof effectively to anticipate or suggest applicants' presently claimed invention. Claims 2-9, which depend from claim 1, are allowable for the same reasons described herein for claim 1, claims 12-17, which depend from claim 11, are allowable for the same reasons described herein for claim 11, claim 20, which depends from claim 10, is allowable for the same reasons described herein for claim 21, which depends from claim 19, is allowable for the same reasons described herein for claim 19, and claim 21, which depends from claim 19. Accordingly, reconsideration and withdrawal of this rejection are respectfully requested.

All claims 1-21 are now proper in form and patentably distinguished over all grounds of rejection cited in the Office Action. Accordingly, allowance of all claims 1-21 is respectfully requested.

Should the Examiner deem that any further action by the applicants would be desirable to place this application in even better condition for issue, the Examiner is requested to telephone applicants' undersigned representatives.

Respectfully submitted,

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